



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 9589**
Seiji KATSUOKA et al. : Attorney Docket No. 2003_1659A
Serial No. 10/712,373 : Group Art Unit 1709
Filed November 14, 2003 : Examiner Briget P. Ngampa

SUBSTRATE PROCESSING METHOD
AND APPARATUS

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement of June 26, 2007, Applicants hereby elect without traverse Group III, which is drawn to a substrate processing unit and is embodied by claims 9-21.

Having made the required election, a full examination on the merits of the elected group is requested.

Respectfully submitted,

Seiji KATSUOKA et al.

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THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975